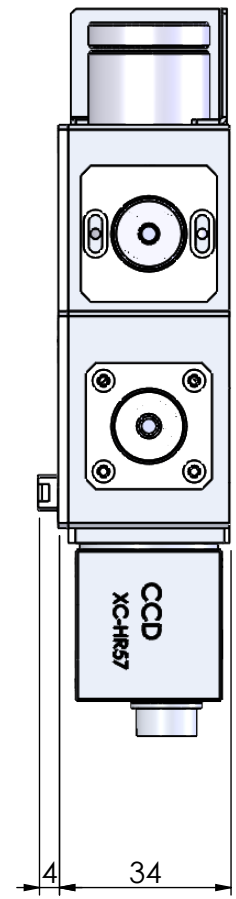
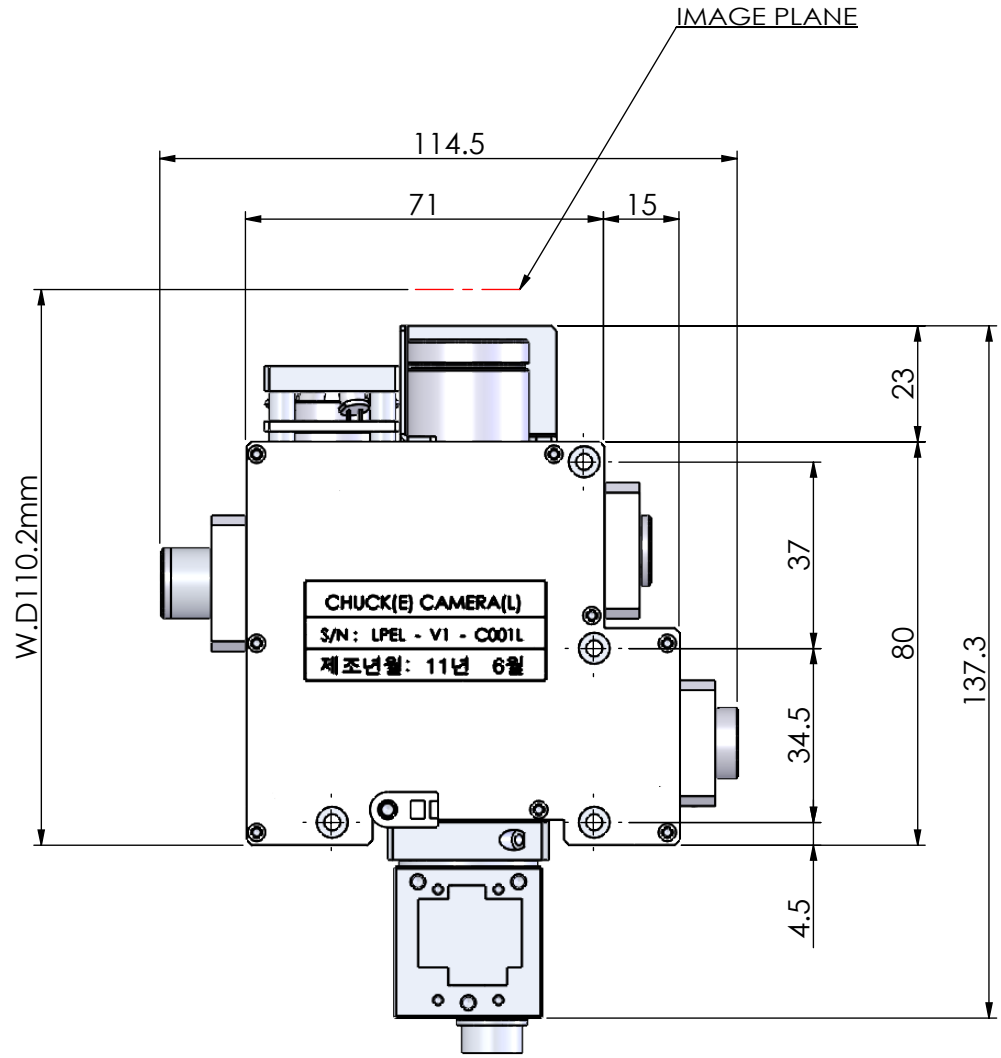


REV. NO	REVISION NOTE	DATE	SIGNATURE	CHECKED
△				

본 도면은 리스광시스템(주)의 자산이므로 허가없이 복제 및 외부 반출을 금함.
 This drawing and ideas are protected by LEES Optical System, Inc.



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OPTICAL MAGNIFICATION	ILLUMINATION	WD (um)	NA	RESOLUTION(um)		DEPTH OF FIELD (um)	SCALE	ANGLE	DESIGNED BY	CHECKED BY	APPROVED BY	TITLE	
				CALCULATION	MONITOR								
1X	COAXIAL/RING	15.2	0.05	6.1	22.08	± 400	1:1.5		항택			ICP EVEN CHUCK(L)	
10X	COAXIAL	10	0.32	0.96	2.19	± 6.2	MM		2016-08-10			LP11013-DL	
												DWG. NO	LP11013-CK-R01-M00(L)